



GE Nuclear Energy

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November 7, 1994

MFN No. 145-94
Docket STN 52-004

Document Control Desk
U. S. Nuclear Regulatory Commission
Washington DC 20555

Attention: Richard W. Borchardt, Director
Standardization Project Directorate

Subject: **PANDA Facility Schematic**

References: PANDA Readiness Assessment Meeting
October 19 through 21, 1994.

This letter transmits color copies of the PANDA Facility Schematics requested by Jack Kudrick at the referenced meeting. This figure is a more detailed version of Figure A.3-7 of NEDO-32391, SBWR Test and Analysis Program Description (TAPD). This version of the schematic includes support systems piping as well as process system piping, and is color coded by support system function.

Sincerely,

P. W. Marriott
P. W. Marriott, Manager
Advanced Plant Technologies

Enclosure: PANDA Facility Schematic.

cc: P. A. Boehnert (ACRS) (w/o attachment)
R. W. Hasselberg (NRC) (w/o attachment)
M. Malloy (NRC) (w/o attachment)
J. A. Kudrick (NRC) (w/1 attachment)

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